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Cantoni is the EM facility manager for materials and basic science at the Swiss Federal Institute of Technology EPFL in Lausanne. He received his PhD degree in experimental physics in the department of solid-state physics at ETH Zurich in 1994. After a stay as a STA (science and technology agency) Fellow in Japan, he joined the electron microscopy center at EPFL in Lausanne. He has studied a wide variety of

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Holzer is a senior scientist at the Institute of Computational Physics in Zurich University of Applied Sciences (ZHAW). His research is focused on microstructure effects related to materials science applications, such as electrodes of solid oxide fuel cells or porous membranes. He received a PhD degree in earth science from the University of Bern (Switzerland) in 1997. Afterward, he worked at the Federal

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Smith is a co-founder and scientist at Oregon Physics LLC. He received his PhD degree in physics from Warwick University in the UK, where he developed a low-energy focused ion beam for high depth resolution SIMS analysis. He has developed ion/electron optics and ion sources for a number of FIB and surface science instrument development companies before co-founding Oregon Physics in 2007. Smith's interests focus on the further development of ion sources and probe forming optics.



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Steele is a co-founder of zeroK Nanotech Corporation, a startup company focused on the commercialization of high-brightness ion sources that utilize laser-cooling. He received his PhD degree in physics from the Georgia Institute of Technology, where he researched laser-cooling of ions with application to nuclear clocks and quantum information processing. Prior to founding zeroK, Steele worked at the National Institute of Standards and Technology

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